



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Walter H. WHITLOCK

Serial No.: 10/643,597

Filed: August 19, 2003

Examiner: Zeinab El Arnini

Group Art Unit: 1746

Attorney Docket: M02A454

Confirmation No.: 3964

Title: PROCESS AND SYSTEM FOR CLEANING SURFACES OF
SEMICONDUCTOR WAFERS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

AMENDMENT AND RESPONSE

In response to the Office Action dated January 12, 2006, please amend the above application as set forth below.

Amendment to the claims begins on page 2 of this response.

Remarks begin on page 7 of this response.